



Commissioner for Patents
Washington, DC 20231
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CONFIRMATION NO. 9732

Bib Data Sheet

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|-----------------------------|-----------------------------------|--------------|------------------------|--|
| SERIAL NUMBER 10/089,176 | FILING DATE 08/20/2002 RULE | CLASS 356 | GROUP ART UNIT 2877 | ATTORNEY DOCKET NO. 0456636-5057 |
|-----------------------------|-----------------------------------|--------------|------------------------|--|

APPLICANTS

Jacques Baudon, Paris, FRANCE;
Jacques Robert, Paris, FRANCE;

** CONTINUING DATA *****

This application is a 371 of PCT/FR00/02664 09/27/2000 *ahl*

** FOREIGN APPLICATIONS *****

FRANCE 99/12016 09/27/1999 *ahl*

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|--|----------------------------|----------------|--------------------|-------------------------|
| Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no | STATE OR COUNTRY FRANCE | SHEETS DRAWING | TOTAL CLAIMS 13 | INDEPENDENT CLAIMS 1 |
| 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after allowance <i>ahl</i> | | | | |

ADDRESS

09629

TITLE

Method and device for atomic interferometry nanolithography

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| FILING FEE RECEIVED 1020 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other <input type="checkbox"/> Credit |
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